





PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE In re application of

Hidemitsu AOKI, et al.

Docket No: Q68480

Appln. No.: 10/071,184.

Group Art Unit: 2823

FECHNOLOGY CERTER 2800

Confirmation No.: 2961 Filed: February 11, 2002 For:

Examiner: Michelle Estrada

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP NON-FEE AMENDMENT Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

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In response to the Office Action dated May 6, 2003, please consider the remarks as submitted herewith on the accompanying pages.